



Docket No. 740819-617

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: )  
Kenji ORITA et al. ) Group Art Unit: 2814  
Serial No. 09/986,997 ) Examiner: Long Pham  
Filed: November 13, 2001 )  
For: METHOD OF FABRICATING SEMICONDUCTOR ) Confirmation No.: 6386  
DEVICE HAVING GROUP III NITRIDE )

**CERTIFICATE OF MAILING OR TRANSMISSION**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to: Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at (703) 872-9306 on March 3, 2004.

*Angelique H. Graham*  
Angelique Graham

**AMENDMENT**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1540  
Alexandria, Virginia 22313-1450

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Sir:

In response to the non-final Office Action mailed December 3, 2003, please consider the amendments and remarks in connection with the above-identified application as follows.

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